

FORM PTO 1449 (modified)			ATTY DOCKET NO. 2004_0468A	SERIAL NO. NEW			
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			APPLICANT Jyun IWASHITA et al.				
LIST OF REFERENCES CITED BY APPLICANT(S) <i>(Use several sheets if necessary)</i>			FILING DATE March 25, 2004				
Date Submitted to PTO: March 25, 2004							
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
SJL	AF	0 232 972	9/1993	Europe			
	AG	8-3635	1/1996	Japan			yes
	AH	2001-174993	6/2001	Japan			abstract
	AI	2002-278069	9/2002	Japan			abstract
	AJ	2002-371114	12/2002	Japan			abstract
	AK	2000-206694	7/2000	Japan			abstract
↓	AL	8-259626	10/1996	Japan			abstract
	AM						
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
SJL	AN	Tsuchiya, Y. et al., Journal of Photopolymer Science and Technology; Vol. 10, No. 4, pp. 579-584, (1997)					
	AO	Maeda, K. et al., Journal of Photopolymer Science and Technology; Vol. 11, No. 3, pp. 507-512, (1999).					
	AP	Iwasa, S. et al., SPIE Advance in Resist Technology and Processing, Vol. 3333, pp. 417-424, (1998).					
EXAMINER			DATE CONSIDERED		4-15-05		

**EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of form with next communication to applicant.*